

Notice of References Cited

Application/Control No.

10/010,850

Applicant(s)/Patent Under

Reexamination

CLEWS ET AL.

Examiner

Binh X Tran

Art Unit

1765

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,123,865	09-2000	Lin et al.	216/91
	B	US-5,851,928	12-1998	Cripe et al.	438/748
	C	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Gennissen et al., "Sacrificial Oxide Etching Compatible with Aluminum Metallization", Proceedings of the 1997 International Conference on Solid-State Sensors and Actuators, Transducer '97, pp. 225-228, June 16-19, 1997.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.